## DECLARATION OF CONFORMITY

| Application of Council Directive(s): <br> Manufacturer's Name: | 89/336/EEC - The EMC Directive |
| :---: | :---: |
|  | Axiomatic Technologies Corporation |
|  | 5915 Wallace Street |
|  | Mississauga, Ontario Canada L4Z 1 Z8 |
| Equipment Type/Environment: | Connector Amplifier |
|  | (Proportional Valve Controller/Amplifier) |
| Trade Name/Model No: | Axiomatic P/N: AX020300, AX020301, AX020302, CAPV-H-4-20MA-x |
|  | Where $x=2 \mathrm{~A}, 1.6 \mathrm{~A}, 1.2 \mathrm{~A}, 800 \mathrm{MA}, 600 \mathrm{MA}$ or 300MA |
| Year of Manufacture: | 2000/2001/2002/2003/2004/2005/2006/ |
|  | 2007/2008/2009/2010/2011/2012/2013/2014/2015/2016/ |
|  | 2017/2018/2019/2020/2021 |
| Accredited Testing Facility: | Canadian Standards Association |
|  | 178 Rexdale Blvd., Etobicoke, ON |
|  | Canada M9W 1R3 |
|  | TEL: 416-747-4000 |
| File No: | SC114262-3 |
| Records Maintained by: | Axiomatic Technologies Corporation |
|  | 5915 Wallace Street, Mississauga, ON |
|  | Canada L4Z 1Z8 |
|  | TEL: 905-602-9270 |

## Standard(s) to which Conformity is Declared:

## Emissions:

| EN 50081-2: 1993 | Generic Emissions for Industrial Environment |
| :--- | :--- |
| EN55011: 1991 | Class A Limits and Methods of Measurement of Electromagnetic (Radio) |
|  | Disturbance Characteristics of Industrial, Scientific and Medical (ISM) |
|  | Radio-Frequency Equipment |

## Immunity:

EN50082-2: 1995 (Generic Immunity for Industrial Environment)
EN 61000-4-2: 1995 Electrostatic Discharge (4kV contact, 8kV air) Performance Criteria A EN 61000-4-3: 1996/ ENV 50204: 1996 Radiated RF Immunity ( $10 \mathrm{~V} / \mathrm{m}, 80-1,000 \mathrm{MHz}, 1 \mathrm{kHz} 80 \% \mathrm{AM}$ Modulation; 900 MHz , pulsed at 200 Hz ), Performance Criteria A

I, the undersigned, hereby declare that the equipment specified above conforms to the above Directive and Standards.

## Manufacturer

Amanda Wilkins
Marketing Manager
Axiomatic Technologies Corporation
January 31, 2021*
Mississauga, Ontario
*Original Declaration dated March 27, 2000

